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**U.S. PATENT DOCUMENTS**

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## FOREIGN PATENT DOCUMENTS

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**OTHER DOCUMENTS** (including Author, Title, Date, Pertinent pages, etc.)

/CI/	International Search Report for PCT/GB2004/002880 dated 21 October 2004.
/CI/	United Kingdom Search Report for GB 0315526.4 dated 30 December 2003.
/CI/	Burns, <i>Resonant Microbeam Sensors</i> , Scientific Honeyweller, 1996, pp. 96-108, XP000678075.
/CI/	Baglio et al., <i>Modeling and design of novel photo-thermo-mechanical microactuators</i> , Sensors and Actuators A, vol. 101, no. 1-2, 30 September 2002, pp. 185-193, XP004380168.
/CI/	Corbeil et al., <i>Self-leveling uncooled microcantilever thermal detector</i> , Applied Physics Letters, vol. 81, no. 7, 12 August 2002, pp. 1306-1308, XP 012033261.
/CI/	Zhao et al., <i>Optomechanical Uncooled Infrared Imaging System: Design, Microfabrication, and Performance</i> , Journal of Microelectromechanical Systems, vol. 11, no. 2, April 2002, pp. 136-146, XP001125207.
/CI/	Sturm, <i>Silicon Temperature Measurement by Infrared Absorption: Fundamental Processes and Doping Effects</i> , IEEE Transactions on Electron Devices, vol. 39, no. 1, 1992, pp. 81-88, XP002299734.

**\*Examiner**

/Carolyn Igyarto/

**Date Considered**

01/07/2008

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